

#171 RCB
PATENT APPLICATION
6/1/03
GR

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

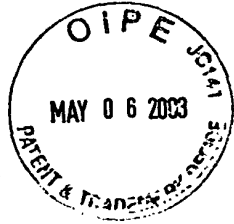
In re the Application of

Ichio YUDASAKA et al.

Application No.: 09/936,041

Filed: December 18, 2001

For: METHOD FOR MANUFACTURING A THIN-
FILM TRANSISTOR COMPRISING A
RECOMBINATION CENTER (AS AMENDED)



Group Art Unit: 2812

Examiner: A. Roman

Docket No.: 110553

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination and entry and consideration of the April 8, 2003 Response to Restriction Requirement and Amendment After Final Rejection. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 141871 in the amount of ☒ \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Robert Z. Evora
Registration No. 47,356

JAO:RZE/cfr

Attachment:
Petition for Extension of Time

Date: May 6, 2003

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

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TECHNOLOGY CENTER 2800

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